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**INFORMATION DISCLOSURE
STATEMENT BY APPLICANT**

(Use as many sheets as necessary)

Sheet	1	of	1	Application Number	10/667,390
				Filing Date	September 23, 2003
				First Named Inventor	Tongbi Jiang
				Art Unit	HA 2878
				Examiner Name	Not Yet Assigned Kevin Wyatt
				Attorney Docket Number	M4065.0906/P906

U.S. PATENT DOCUMENTS

Examiner Initials*	Cite No. ¹	Document Number	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
		Number-Kind Code ² (if known)			
J. W.	AA	US-5,672,519	09-30-1997	Song et al.	1

FOREIGN PATENT DOCUMENTS

Examiner Initials*	Cite No. ¹	Foreign Patent Document	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	T ⁶
		Country Code ³ -Number ⁴ -Kind Code ⁵ (if known)				

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NON PATENT LITERATURE DOCUMENTS

Examiner Initials*	Cite No. ¹	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T ²
J. W.	CA	Air-Channel Fabrication for Microelectromechanical Systems Via Sacrificial Photosensitive Polycarbonates, Joseph Paul Jayachandran, Hollie A. Reed, Hongshi Zhen, Larry F. Rhodes, Clifford L. Henderson, Sue Ann Bidstrup Allen, and Paul A. Kohl, School of Chemical Engineering, Georgia Institute of Technology, Atlanta, GA (b) Promerus LLC, Brecksville, OH	
J. W.	CB	Fabrication of microchannels using polycarbonates as sacrificial materials, Hollie A. Reed, Celesta E. White, Vikram Rao, Sue Ann Bidstrup Allen, Clifford L. Henderson and Paul A. Kohl, School of Chemical Engineering, Georgia Institute of Technology, Atlanta, GA, October 12, 2001, Journal of Micromechanics and Microengineering, Institute of Physics Publishing, J. Micromech, Microeng. 11 (2001) 733-737	
J. W.	CC	Fabrication of Air-Channel Structures for Microfluidic, Microelectromechanical, and Microelectronic Applications, Dhananjay Bhusari, Hollie A. Reed, Michael Wedlake, Agnes M. Padovani, Sue Ann Bidstrup Allen, and Paul A. Kohl, Member, IEEE, Journal of Microelectromechanical System, Vol. 10, No. 3, September 2001	

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